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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:

Kimiaki Ando et al.

SERIAL NO.:

09/935,185

**FILED** 

August 22, 2001

**FOR** 

ELECTRON-BEAM DRAWING APPARATUS AND ELECTRON-

**BEAM DRAWING METHOD** 

**ART UNIT** 

2881

EXAMINER:

PHILLIP A. JOHNSTON

**COMMISSIONER FOR PATENTS** P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

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AMENDMENT

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IECTHOLOGY CENTER 2003

AMENDMENT

In response to the Office Action of April 2, 2003, the period for response expiring July 2, 2003, please amend the above-identified application as follows: